



60/2827

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Naoki AYAI
Title: OXIDE HIGH-TEMPERATURE
SUPERCONDUCTING WIRE AND
METHOD OF PRODUCING THE
SAME
Appl. No.: 09/938,829
Filing Date: 08/27/01
Examiner: Tuan T. Dinh
Art Unit: 2827

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CERTIFICATE OF MAILING

Assistant Commissioner for Patents
Washington, D.C. 20231


Assistant Commissioner:

I hereby certify that the following paper(s) and/or fee along with any attachments referred to or identified as being attached or enclosed are being deposited with the United States Postal Service as First Class Mail under 37 C.F.R. § 1.8(a) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Assistant Commissioner for Patents, Washington D.C. 20231.

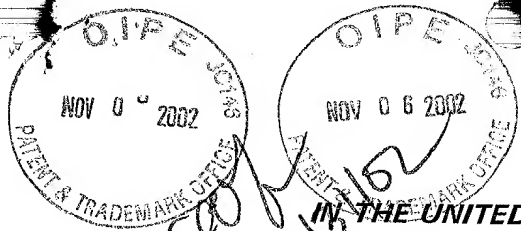
1. Amendment and Request for Reconsideration Under 37 C.F.R. § 1.111
2. Mark-up copy of Amendment and Request for Reconsideration Under 37 C.F.R. § 1.111
3. Postcard

Respectfully submitted,

October 31, 2002
Date


David A. Blumenthal
Reg. No. 26,257

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Atty. Dkt. No. 040256-0123

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#9/A
must
J. manilla
11/7/02

AMENDMENT AND REQUEST FOR RECONSIDERATION
UNDER 37 C.F.R. § 1.111

Commissioner for Patents
Box Non-Fee Amendment
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed July 31, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 2 and 11-23. Applicant reserves the right to file a divisional application on the non-elected claims. Please amend claims 1 and 3-10 as follows.

- AI
1. (Amended) An oxide superconducting wire comprising:
oxide superconductors;
a ceramic layer enclosing each of said oxide superconductors, said ceramic layer becoming non-conducting at an operational temperature of said oxide superconductors;
a metal sheath directly coating said ceramic layer; and

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